PTC/SB/05A(10-01)
Approved for use through 10/31/2002, OMB 651-0031
Patent & Trademark Office: U.S. DEPARTMENT OF COMMERCE

Substitute for form 1449A/PTO Complete If Known INFORMATION DISCLOSURE **Application Number** 10/789,800 STATEMENT BY APPLICANT (Use as many sheets as necessor) E IAA February 27, 2004 **Filing Date** Torek, Kevin **First Named Inventor Group Art Unit** 2818 Unknown **Examiner Name** Attorney Docket No: 303.871US1 Sheet 1 of 1

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